

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Present Application:

Applicants : Dinesh Chopra and
Scott G. Meikle

Attorney Docket No. : 500077.12

Filed : Concurrently herewith

Title : METHODS AND APPARATUSES FOR MECHANICAL AND CHEMICAL-
MECHANICAL PLANARIZATION OF MICROELECTRONIC-DEVICE
SUBSTRATE ASSEMBLIES ON PLANARIZING PADS

Prior Application:

Examiner : Jimmy T. Nguyen

Art Unit : 3725

Serial No. : 10/300,344

PRELIMINARY AMENDMENT

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on
page 3 of this paper.

Remarks begin on page 5 of this paper.